

RESPONSE UNDER 37 CFR 1.116 - EXPEDITED
PROCEDURE - EXAMINING GROUP 1104

#38/00
9-26-97



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Shunpei YAMAZAKI et al.

Serial No. 08/183,800

Filed: January 21, 1994

For: SEMICONDUCTOR MATERIAL

AND METHOD FOR FORMING

THE SAME AND THIN FILM

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GROUP 1100) Examiner S. Crane

SEP 24 1997

) Art Unit: 2508

GROUP 2500

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) September 10, 1997

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on September 10, 1997.

Ingeborg S. Alexander

Ingeborg S. Alexander

DO NOT
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AMENDMENT AFTER FINAL

Honorable Assistant Commissioner for Patents

BOX AF

Washington, D.C. 20231

Sir:

In response to the Office Action mailed June 10, 1997, please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend claims 32, 36, 37 and 38 as follows:

32. (Four Times Amended) A thin film transistor produced by a process comprising the steps of: